

33082M280

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Yasuo KOBAYASHI, et al.

U.S. Serial No.: 10/549,859

Group Art Unit: To Be Assigned

Filed: : June 6, 2006

Examiner: To Be Assigned

For: PLASMA-ASSISTED DEPOSITION METHOD AND PLASMA-ASSISTED
DEPOSITION SYSTEM

THIRD INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

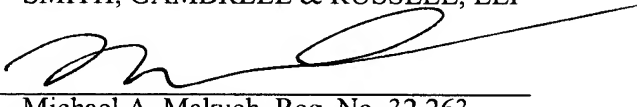
Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the documents cited in the European Search Report issued for this counterpart Appln. No. EP0 4 722 947 dated February 6, 2007. According to the Annex to the Search Report, U.S. Patent No. 6,544,901 is a family member of EP 1 035 569. U.S. Patent No. 6,544,901 was previously cited in an Information Disclosure Statement filed September 23, 2005.

Applicants certify under 37 C.F.R. 1.97(e)(1) that all documents submitted herewith were cited in a communication from a foreign patent office in a counterpart foreign application no more than three months prior to the filing of this Statement. Therefore, it is respectfully urged that no fees are required for the Examiner's consideration of the documents listed in this Information Disclosure Statement.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,
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April 19, 2007



TFW 1762



FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT	ATTY. DOCKET 33082M280	SERIAL NO. 10/549,859
	APPLICANT: Yasuo KOBAYASHI, et al.	
	FILING DATE June 6, 2006	GROUP ART UNIT To Be Assigned

U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE, IF APPROPRIATE
	AA	6,357,385	3/19/02	Ohmi et al.			
	AB	5,134,965	8/4/92	Tokuda et al.			
	AC	5,698,036	12/16/97	Ishii, et al.			
	AD						
	AE						
	AF						
	AG						

FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION	
							YES	NO
	AH	EP 0 1 035 569	9/13/00	EPO				
	AI							
	AJ							
	AK							
	AL							
	AM							
	AN							
	AO							
	AP							
	AQ							
	AR							

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

	AS	
	AT	

EXAMINER:	DATE CONSIDERED:
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>	